

Research Article

Sub-Nanosecond Greater-Than-10-V Compact Tunable Pulse Generator for Low-Duty-Cycle High-Peak-Power Ultra-Wideband Applications

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An ultra-wideband pulse generator was designed and fabricated in GaAs HBT IC technology. The generator includes delay and differential circuits to convert a TTL input into a Gaussian pulse signal as well as a Class-C amplifier to boost the pulse amplitude while compressing the pulse width. By adjusting the collector bias of the Class-C amplifier, the pulse amplitude can be varied linearly between 3.5 V and 11.5 V while maintaining the pulse width at 0.3 ± 0.1 nanosecond. Alternatively, by adjusting the base bias of the Class-C amplifier, the pulse width can be varied linearly between 0.25 ns and 0.65 ns while maintaining the pulse amplitude at 10 ± 1 V. Finally, the amplified Gaussian signal can be shaped into a monocycle signal by an *L-C* derivative circuit. The present pulse generator compares favorably with pulse generators fabricated in CMOS ICs, step-recovery diodes, or other discrete devices.

1. Introduction

ULTRA-wideband (UWB) impulse radio [1] is attractive for applications such as through-wall imaging, precision navigation, location, and tracking. A UWB impulse radio can be particularly attractive for high-resolution ranging applications, if low-duty-cycle high-peak-power transmitters can be readily assembled from sub-nanosecond high-voltage pulse generators. Additionally, pulse generators capable of tunable amplitude and width can enhance the functionality of the UWB impulse radio. For example, the pulse amplitude can be adjusted according to the range of interest, while the pulse width can be varied to inspect objects at different depths inside a wall.

Sub-nanosecond high-voltage pulse generators are required by low-duty-cycle high-peak-power UWB transmitters to maximize their performance without exceeding the FCC limits of -41.3 dBm/MHz and 0 dBm/50 MHz for average and peak powers, respectively [2]. For pulse-repetition frequencies of 187.5 kHz or lower, peak power instead of

average power is the main limit. In this case, for a pulse width of 0.5 nanosecond, the pulse amplitude can be as high as 8.9 V on a 50- Ω load [3]. Considering connector loss, antenna mismatch, and so forth, sub-nanosecond greater-than-10-V pulse generators are required.

To satisfy the aforementioned requirement, we designed [4] a sub-nanosecond greater-than-10-V tunable pulse generator by using the GaAs HBT IC technology. As shown in Figure 1 and Table 1, this pulse generator could generate much higher pulse amplitude than pulse generators based on Si CMOS or BiCMOS ICs. It was also much more compact than pulsed generators based on step-recovery diodes (SRDs) and other discrete devices. This paper expands on [4] mainly by discussing in detail the device modeling, circuit design, simulation, and testing of the present pulse generator. Additionally, modeling, simulation, and testing of the temperature stability of the pulse generator are presented, stability over four orders of pulse-repetition frequencies is characterized at different temperatures, output power

TABLE 1: Performance of UWB pulse generators.

Technology	Waveform	Pulse amplitude (V)	Pulse width (nanosecond)	Power cons. (mW)	Supply voltage (V)	Die size (mm ²)	Eff. (%)	Jitter (ps)	Ref.
GaAs HBT	Impulse	3.5–11.5	0.25–0.65	120	3.3–14	0.95 × 0.95	—	<1.5	[4]
	Monocycle	5.1–8.8	0.2–1.0	—	—	—	0.8	—	—
GaAs HEMT	Impulse	0.7	0.06	120	—	1.5 × 1.2	—	0.5–1.5	[11]
Si SRD	Monocycle	8	0.6–1.1	—	18	40 × 60	—	—	[12]
	Impulse	4.35	0.25	—	15	60 × 60	—	—	[13]
Si BJT	Monocycle	1.3	0.5	—	—	—	—	—	[14]
	Impulse	1.4	0.4	—	2.5	0.3 × 0.25	—	—	[15]
	Monocycle	0.3–0.6	0.14–0.35	—	—	—	—	—	—
Si MOSFET	Impulse	2.8	0.5	—	3.3	0.5	—	—	[16]
	Impulse	1.2	2.0	0.72	1.8	1.71 × 0.71	—	—	[17]
	Monocycle	3.7	0.5	—	—	—	—	—	[18]
	Impulse	0.03–0.12	0.07–0.18	17	1	0.0068	—	—	[19]
	Monocycle	0.66	0.38	19.8	1.2	0.25	2.6	—	[20]
	Monocycle	0.175	0.3	0.18	1.8	0.175 × 0.175	—	—	[21]

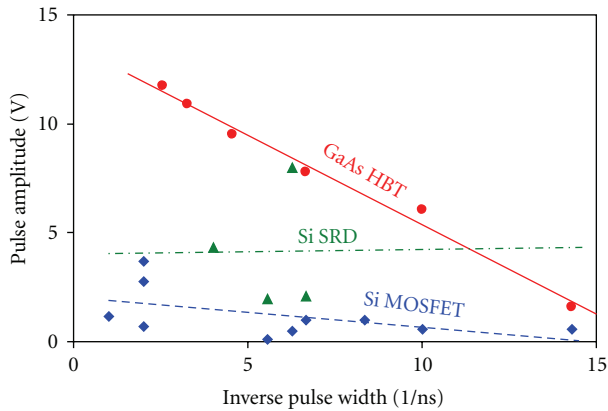
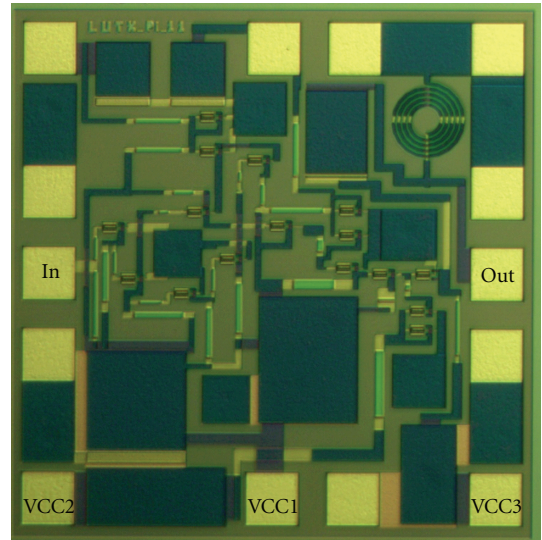


FIGURE 1: Output pulse amplitude as a function of inverse pulse width for UWB pulse generators of different technologies.

spectrum is compared with the FCC mask, and the effect of load impedance is modeled and measured.

2. Device Technology and Modeling

The GaAs HBT IC technology is chosen for not only its superior combination of high-voltage and high-frequency characteristics to that of Si CMOS or BiCMOS IC technology but also its much enhanced output power capacity for low-duty-cycle isothermal operation [5], which helps compact the size of the pulse generator. Because the thermal conductivity of GaAs is three times lower than that of Si, ordinarily, the power capacity of GaAs HBTs is limited by thermally induced current collapse [6]. However, this is not an issue under low-duty-cycle isothermal operation. So the traditional design approach is not suitable to GaAs HBT

FIGURE 2: Micrograph of the $\sim 1 \text{ mm}^2$ GaAs HBT IC pulse generator.

pulse generator. In our design, a Darlington pair is used to keep the main amplifier at the same temperature, which greatly enhances the output power of the pulse generator. Used in most mobile phones, the GaAs HBT technology is also relatively mature and low cost. In comparison, GaAs HEMTs often suffer from gate lag while GaN HEMTs are less mature.

Figure 2 shows the tunable pulse generator fabricated by a commercial GaAs HBT foundry [7]. The die size is less than $1 \text{ mm} \times 1 \text{ mm}$, which includes not only all HBTs but also all bias resistors, capacitors, and DC/RF probe pads. To ensure compact size and wideband performance, the pulse generator

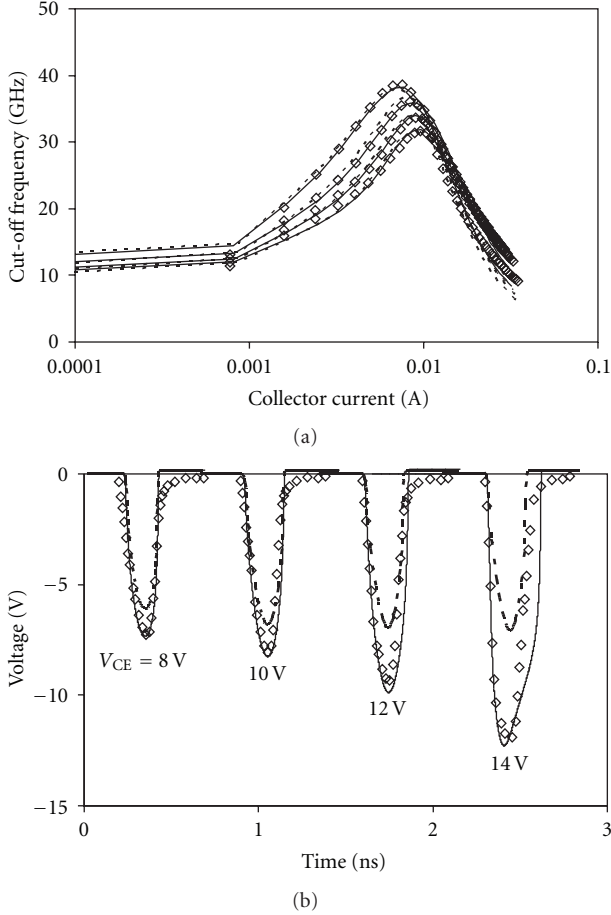


FIGURE 3: Measured (symbol) (a) cutoff frequency f_T and (b) impulse response of a typical HBT versus that simulated by using the Agilent (dashed curve) and modified (solid curve) HBT model. In (a), $V_{CE} = 1, 2, 3,$ and 4 V top down. In (b), the input pulse width and amplitude are 0.2 nanosecond and 1.45 V, respectively. $V_{BE} = 0$. Artificial delays between impulses are added for clarity.

contains only one small inductor, which is part of the L-C derivative circuit. Extra probe pads are included for diagnosis but are not required for establishing the circuit performance. The die size could have been at least halved but was laid out to match the footprint of other circuits.

Typically, the HBTs have a current-gain cutoff frequency f_T of 40 GHz, a maximum frequency of oscillation f_{MAX} of 60 GHz, a common-emitter breakdown voltage BV_{CEO} of 15 V, and a common-base breakdown voltage BV_{CBO} of 30 V. For accurate simulation of sub-nanosecond high-voltage operation, a modified HBT model [8, 9] was extracted and then implemented in the ADS [10] circuit design environment.

Power is the product of current and voltage. Ordinarily, the HBT current is limited by the Kirk (base push-out) effect, which is highly temperature-dependent, while its voltage is limited by thermal runaway [6]. Under isothermal operation, we found that the HBT current and voltage capacities could be greatly extended, resulting in much higher power output. In this case, the Kirk effect is not only current-dependent but also voltage-dependent, and the maximum voltage is

limited by avalanche breakdown instead of thermal runaway. However, since the commercially available Agilent HBT model [10] includes limited Kirk effect and no breakdown, we modified it by adding stronger voltage dependence to the conventional Kirk model and current dependence to the conventional breakdown model.

Specifically, the Kirk charge Q_K in the Agilent HBT model is replaced with the following:

$$Q_K = \frac{I_F W_{CIB}^2}{4D_{NC}}, \quad (1)$$

where I_F is the forward current from the collector to the base, W_{CIB} is the extended width of the base, and D_{NC} is the electron diffusivity in the extended base. W_{CIB} is defined as

$$W_{CIB} = W_C - \sqrt{\frac{2\varepsilon V_{CBK}}{(I_F/A_E v_{SAT} - qN_C)}}; \quad (2)$$

$$\frac{1}{v_{SAT}} = \frac{1}{v_{SAT0}} + k\Delta T,$$

where W_C is the collector width, ε is the GaAs permittivity, A_E is the emitter area, q is the electron charge, N_C is the collector doping, ΔT is the difference between junction temperature T and room temperature T_0 , v_{SAT} and v_{SAT0} are saturated electron velocities at T and T_0 , respectively, and k is a fitting parameter. Equation (2) follows the conventional form [22] except that V_{CBK} is dependent on $V_{CB} + V_{BI}$ superlinearly:

$$V_{CBK} = (V_{CB} + V_{BI}) \left\{ 1 + \left[\frac{(V_{CB} + V_{BI})}{V_{CK}} \right]^{CK} \right\}, \quad (3)$$

where V_{CB} and V_{BI} are the bias and built-in voltages of the collector-base junction, and V_{CK} and CK are fitting parameters. Meanwhile, D_{NC} is also made current-dependent:

$$D_{NC} = D_{NC0} \left(\frac{I_C}{I_{KCR}} \right)^{-GK} \left(\frac{T}{T_0} \right), \quad (4)$$

where D_{NC0} is the low-field electron diffusivity in the collector and I_{KCR} and GK are fitting parameters. Finally, as in the Agilent HBT model, Q_K is partitioned between the collector and base:

$$Q_{CK} = F_{EXKE} Q_K, \quad Q_{BK} = (1 - F_{EXKE}) Q_K, \quad (5)$$

where F_{EXKE} is yet another fitting parameter.

Current dependence is added to the breakdown model through an additional hyper-cosine term in the multiplication factor M while temperature dependence is captured by a power term:

$$M = 1 + m \cosh[(I_F - A_E N_C q v_{SAT}) V_{CB}] \tan \left[\left(\frac{\pi}{2} \right) \left(\frac{V_{CB}}{BV_{CBO}} \right)^n \right] \left(\frac{T}{T_0} \right)^{-XM}, \quad (6)$$

where m , n , and XM are fitting parameters.

To properly account for the transport across the HBT collector, self-consistent solutions are usually obtained for

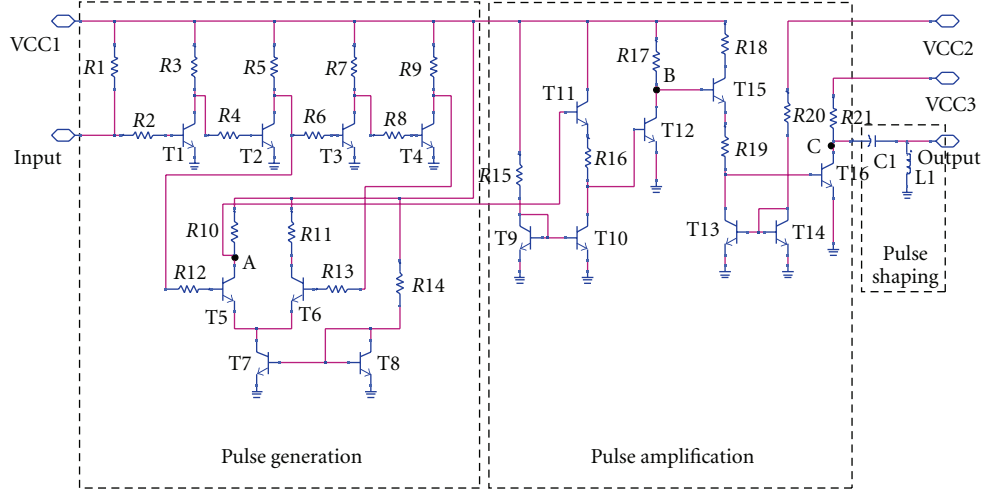


FIGURE 4: Circuit schematics showing the pulse generator comprises the pulse generation, amplification, and shaping blocks.

the Poisson and drift-diffusion equations, which are coupled through the electric field. Under low currents, abrupt-depletion and quasineutral approximations apply; so the field varies linearly in the depletion region and is nil in the undepleted collector. However, under high currents, space charge density varies significantly in the collector and the field distribution becomes highly nonlinear. For example, the collector can be totally depleted and the field can even be reversed. Under such complicated field distribution, the numerical solutions are too complicated for compact modeling [5]. Therefore, instead of exact solutions, we empirically added the current dependence in (6) to account for the high-current effect on the field distribution and, in turn, the multiplication factor. Similarly, when the field distribution in the collector becomes very complicated, so does the electron velocity in the collector. However, we retained the constant v_{SAT} in (2) and (6) and approximated the effect of velocity variation across the collector with additional voltage and current dependence in (3), (4), and (6). In this case, “ v_{SAT} ” represents some weighted average of the velocity variation and may deviate from the commonly assumed value of 10^7 cm/s.

With proper account of the Kirk and breakdown effects under high-voltage high-current operations, the collector current I_C can be modeled as

$$I_C = I_{BC} + \frac{d(Q_{TB} + Q_{TC} + Q_{CK})}{dt} + MI_F, \quad (7)$$

where the base-collector diode current I_{BC} and the base and collector delay charges Q_{TB} and Q_{TC} are from the original Agilent HBT model.

The above-modified HBT model was coded in Verilog-A [23] and installed in ADS [10] to aid the circuit design. Figure 3 shows that while both the Agilent and the modified models can fit the small-signal HBT characteristics, the modified model is superior to the Agilent model in predicting the HBT impulse response. Therefore, the modified HBT model is used in the design of pulse generators as described in the following.

3. Circuit Design

Figure 4 shows schematically the circuit design of the pulse-generation, pulse-amplification, and pulse-shaping blocks of the pulse generator. The pulse-generation block includes a delay chain of HBTs T_1 , T_2 , T_3 , and T_4 and a differential amplifier of HBTs T_5 and T_6 . T_5 and T_6 are driven by T_2 and T_4 , respectively. The delay time τ between T_2 and T_4 is dominated by the R - C time constant of the load resistance on the collector of each HBT and the load capacitance between the collector of one HBT and the base of the next HBT. For the present HBTs, $R \approx 1000 \Omega$ and $C \approx 0.2$ pF. Therefore, $\tau \approx 2RC \approx 0.4$ nanosecond and the pulse-generation block can generate sub-nanosecond positive and negative pulses from the falling and rising edges, respectively, of the TTL input (Figure 5). The input amplitude to T_6 is higher than that of T_5 because the base current of T_3 introduces additional voltage drop over R_5 . Once T_6 is conducting, the output of T_5 is clamped at the high voltage whether T_5 is conducting or not. This helps maximize the single-ended output of the differential amplifier T_5 - T_6 while suppressing the generation of positive pulses. At the ensuing Class-C pulse-amplification block, the relatively strong negative pulses are further amplified and sharpened while the relatively weak positive pulses are further suppressed.

The pulse-amplification block includes two Darlington pairs, T_{11} - T_{12} and T_{15} - T_{16} , respectively. T_{12} is biased in the saturation region so that the first Darlington pair serves as the driver amplifier; T_{16} is biased in the cutoff region so that the second Darlington pair acts as a Class-C amplifier. The Class-C bias of T_{16} helps ensure isothermal operation, minimize power consumption, cut off low-voltage ringing, compress pulse width, and prevent oscillation. Current mirrors T_9 - T_{10} and T_{13} - T_{14} limit the currents through T_{11} and T_{15} , respectively. The pulse-shaping block is a simple high-pass L - C derivative circuit. If necessary, higher-order derivative circuits can be added to shape the pulse further and to take advantage of the full bandwidth of 3.1–10.6 GHz.

All HBTs in the pulse generator are of the same design with an emitter area of $2\mu\text{m} \times 20\mu\text{m}$, except that $T16$ has an emitter area of $2\mu\text{m} \times 20\mu\text{m} \times 4$. The collector of $T16$ is shunted to $VCC3$ through a $1\text{ k}\Omega$ resistor, which provides adequate DC-RF isolation and helps reduce ringing. Although this resistor consumes little power as $T16$ is normally off, it cannot be made much bigger without degrading the performance at high pulse-repetition frequencies. When $T16$ is turned on by the input pulse, the output impedance of $T16$ quickly approaches $50\ \Omega$, as evidenced by the absence of ringing or other delayed reflections in both simulation and measurement. This large-signal transient impedance can be adjusted by varying the size and bias of $T16$ to better suit that of the antenna, especially UWB antennas with higher-than- $50\text{-}\Omega$ impedances.

The output pulse width can be tuned by adjusting $VCC2$, which affects the base bias of $T16$ through $R19$. The output pulse amplitude can be tuned by adjusting $VCC3$, which affects the collector bias of $T16$ through $R21$. Usually, the output pulse amplitude of $T16$ may be limited by both self-heating and avalanche breakdown. For the present low-duty-cycle sub-nanosecond pulse generator, self-heating is not a concern because the HBT thermal time constant is on the order of microsecond [5]. Avalanche breakdown is suppressed by adding $R19$ and $T14$ to the base of $T16$ [24]. Typically, $VCC1 = 3.3\text{ V}$, $VCC2 = 2\text{--}5\text{ V}$, and $VCC3 = 4\text{--}14\text{ V}$.

Figure 5 shows the simulated voltage waveforms at the input and output of the pulse generator, as well as the internal nodes A, B, and C labeled on Figure 4. It can be seen that at Node A, negative pulses are generated from the rising edge of a 10 MHz square-wave input signal, while positive pulses generated from the falling edge of the input are barely discernible. The negative pulses are then inverted and amplified once at Node B and twice at Node C, while the positive pulses are completely suppressed. Finally, the output signal becomes monocycle after going through the $L\text{-}C$ pulse-shaping block.

4. Results and Discussion

The fabricated pulse generators were tested by using a previously described setup [8] with the TTL input generated by an HP 8116A function generator. The output waveforms were sampled by an Agilent 86100 oscilloscope and de-embedded to the die input and output pads after accounting for the frequency response of the cable assemblies. Unless otherwise noted, most pulse generators were tested with a $0.5\text{--}2.5\text{-V}$ TTL square signal of 10 MHz pulse-repetition frequency (Figure 5), which corresponds to $<1\%$ duty cycle for the submicron pulses.

As predicted by simulation, Figure 6 shows that the pulse amplitude at Node C of the pulse generator can be tuned linearly between 3.5 V and 11.5 V by varying $VCC3$ from 4 V to 14 V , while maintaining the pulse width within 0.3 ± 0.1 nanosecond. (In this paper, the pulse amplitude is measured peak-to-peak, while the pulse width is the full width at half maximum.) Figure 7 shows that the pulse width at Node C can be tuned linearly between 0.25 nanosecond and 0.65 nanosecond by varying $VCC2$ from 2.5 V to 4.5 V ,

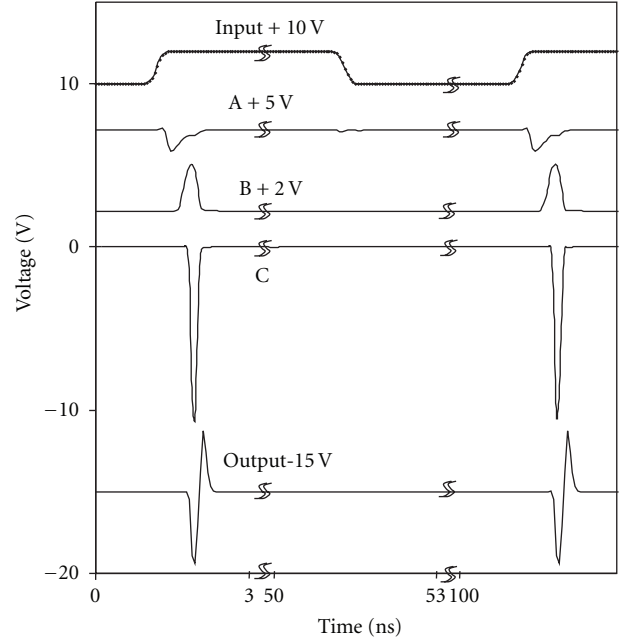


FIGURE 5: Simulated voltage waveforms at the input and output of the pulse generator as well as the internal nodes A, B, and C labeled in Figure 4. The negative pulse generated from the rising edge of the input signal is progressively amplified and shaped, while the positive pulse generated from the falling edge of the input signal is barely discernible at A and is completely suppressed at the output. Artificial offset voltages are added for clarity.

while maintaining the pulse amplitude at $10 \pm 1\text{ V}$. In comparison, $VCC1$ could be varied from 3.3 V to 3.6 V without obvious impact on output pulse amplitude or width. Similarly, no obvious jitter was observed on the oscilloscope with 1.5-ps time resolution. Both Figures 6 and 7 include additional temperature-dependent data. Without adjusting the bias or input conditions, the pulse generator was found to operate similarly well when the ambient temperature was varied from -40°C to 85°C . Figure 6(b) shows that the pulse amplitude at Node C varies by less than 0.2 V across the temperature range measured, except at the highest $VCC3$ when it is limited by the Kirk threshold that decreases with increasing temperature. On the other hand, as shown in Figure 7(b), the pulse width increases with increasing temperature at all $VCC2$ values, because the high-frequency gain decreases with increasing temperature. To further improve the temperature performance of the pulse generator, temperature sensing and compensating circuit can be incorporated to fine-tune $VCC2$.

Following the pulse-shaping block, the pulses at Node C are converted to monocycles at the output. Figure 8 shows that with $VCC2$ varying between 2 V and 6 V , the monocycle amplitude varies from 5.1 V to 8.8 V while its width varies from 0.2 nanosecond to 1.0 nanosecond. The positive and negative portions of the monocycle differ mainly due to the low-quality factor of the inductor. Figure 9 shows the corresponding power spectrum for monocycles generated with $VCC1 = 3.3\text{ V}$, $VCC2 = 6\text{ V}$, and $VCC3 = 13\text{ V}$ under a pulse-repetition frequency of 3 MHz . Obviously, a

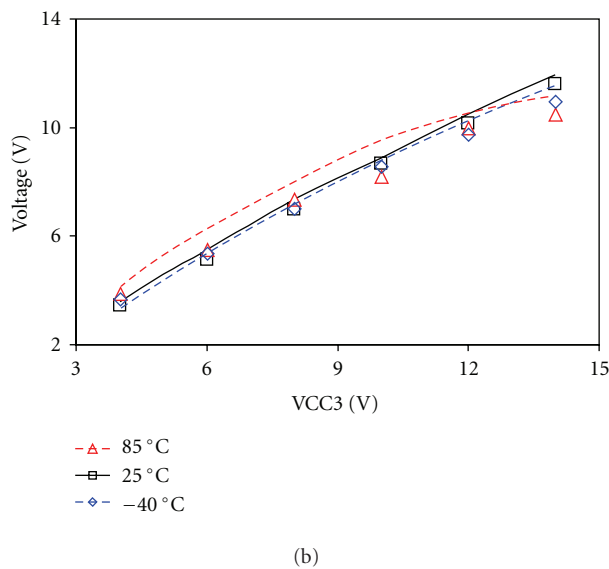
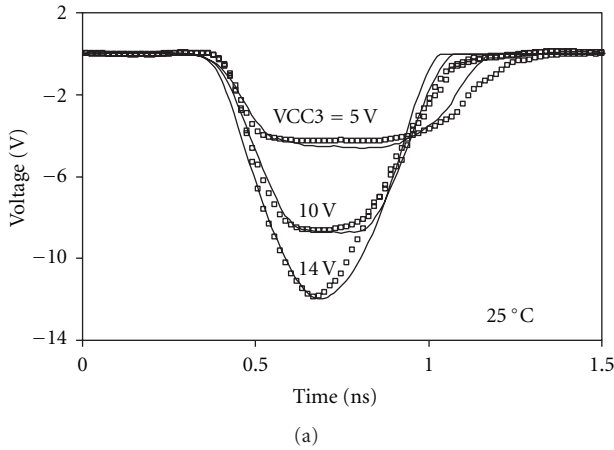


FIGURE 6: Measured (symbol) versus simulated (curve) (a) waveform and (b) pulse amplitude at Node C of the pulse generator with $VCC1 = VCC2 = 3.3$ V, and $VCC3 = 4$ – 14 V.

notch filter around 2 GHz is needed to prevent interference with global positioning systems, cellular communications, and industrial, scientific, and medical instrumentations. On the other hand, the power density elsewhere can be boosted by increasing the pulse-repetition frequency and the entire spectrum can be shifted to higher frequencies by incorporating higher-order derivative circuits. Figure 10 shows that the output amplitude of the pulse generator is stable under different pulse-repetition frequencies between 40 KHz and 25 MHz, which indicates that the isothermal approximation is valid over a wide range of pulse amplitudes and duty cycles.

High impedance antennas are often used in UWB systems; so the pulse generator was evaluated by increasing the load impedance from 50Ω to 200Ω . No oscillation was observed. Figure 11 shows that under a constant input voltage of 2 V and a load impedance of 200Ω , the pulse amplitude at Node C is slightly lower than $VCC3$ by the HBT knee voltage of approximately 1 V. However, at lower load

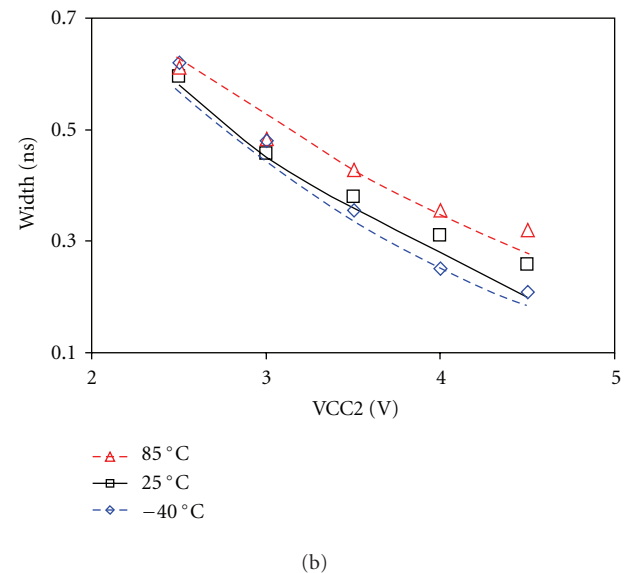
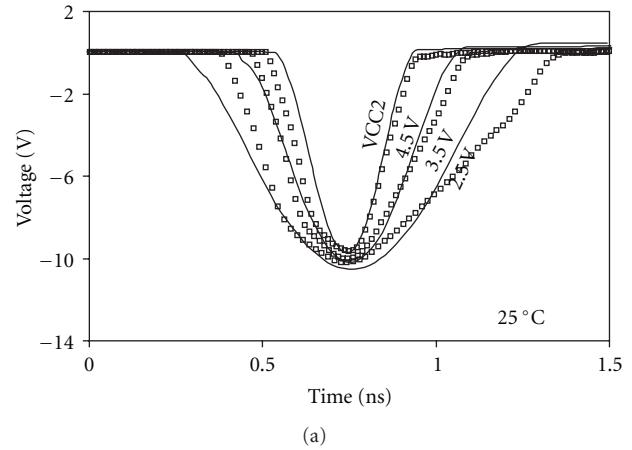


FIGURE 7: Measured (symbol) versus simulated (curve) (a) waveform and (b) width of impulses at Node C of the pulse generator with $VCC1 = 3.3$ V, $VCC2 = 2.5$ – 4.5 V, and $VCC3 = 12$ V.

impedances such as 100Ω and 50Ω , the pulse amplitude saturates at a value much lower than $VCC3$ unless the input voltage is significantly increased to overdrive the pulse generator. In this case, although the pulse generator could output 12 V into different load impedances, the output power would decrease with increasing load impedance. However, if both the input and bias conditions could be fine-tuned at each impedance, then the minimum pulse width would decrease with increasing load impedance, too. For example, after such fine tuning, the minimal pulse widths with 10 V pulse amplitude are 0.25 nanosecond, 0.21 nanosecond, and 0.20 nanosecond for 50Ω , 100Ω , and 200Ω loads, respectively.

The present pulse generator consumes approximately 120 mW, with 100 mW flowing through the pulse-amplification block. As listed in Table 1, the ratio of power consumption over pulse amplitude for the present pulse generator is comparable to that of the pulsed generators made of GaAs HEMTs and Si MOSFETs. The power consumption

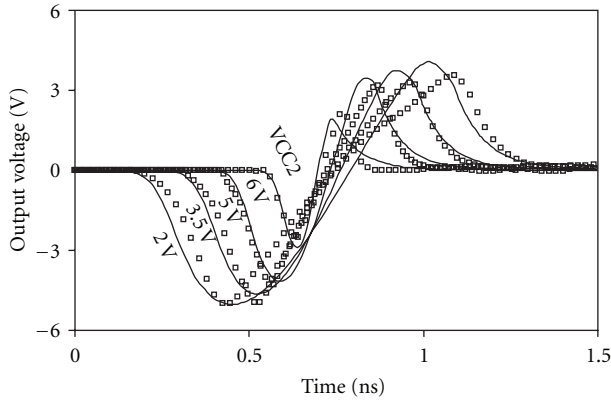


FIGURE 8: Measured (symbol) versus simulated (curve) monocycles generated with $V_{CC1} = 3.3$ V, $V_{CC2} = 2$ –6 V, and $V_{CC3} = 13$ V.

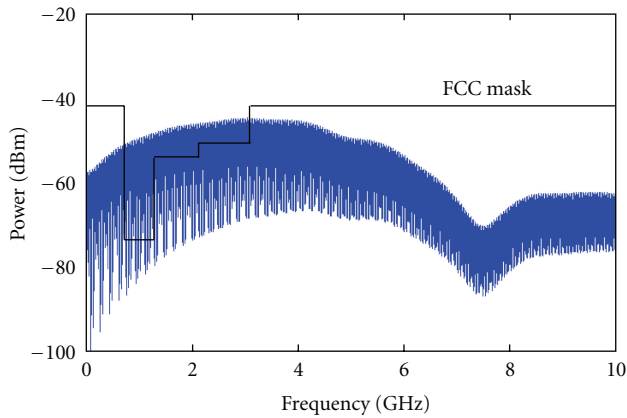


FIGURE 9: Power spectrum of monocycles generated with $V_{CC1} = 3.3$ V, $V_{CC2} = 6$ V, $V_{CC3} = 13$ V, and PRF = 3 MHz.

of the present pulse generator can be reduced by reducing the size of certain HBTs. For example, reducing $T1$ – $T8$, $T9$, and $T14$ from $40 \mu\text{m}^2$ to $8 \mu\text{m}^2$ would save 70% of power. Much greater power can be saved by cycling off the pulse amplifier when no pulse is expected. With an on-time of 1 nanosecond and a pulse-repetition frequency of 10 MHz, the power consumed by the pulse amplifier can be reduced by a factor of 100 to approximately 1 mW. The power saving can be even greater at lower pulse-repetition frequencies. At approximately 1 mm^2 , the die costs less than \$1 for volume production.

5. Conclusion

For low-duty-cycle high-peak-power ultra-wideband applications, a sub-nanosecond greater-than-10-V tunable pulse generator was designed by taking advantage of the recent discovery of much greater output capacity of GaAs HBTs under sub-nanosecond isothermal operation. To aid the circuit design, a commercially available HBT model was modified by adding stronger voltage dependence to the Kirk-effect model and current dependence to avalanche-breakdown model. Using the modified HBT model, the performance of the

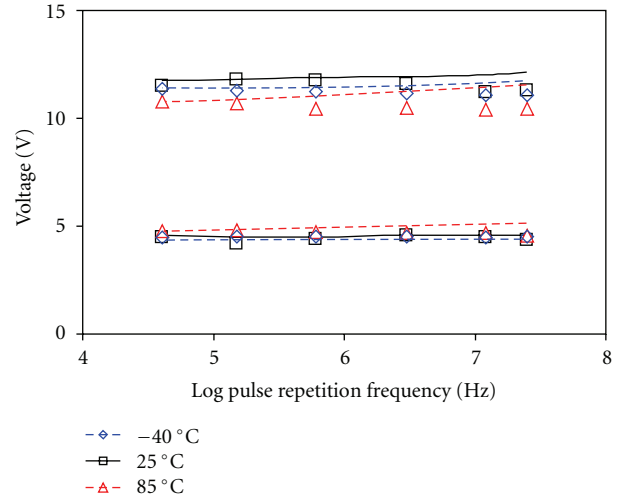


FIGURE 10: Measured output pulse amplitudes under different temperature as functions of pulse-repetition frequency between 40 kHz and 25 MHz. From the bottom up, the biases for pulse generator are $V_{CC1} = 3.3$ V, $V_{CC2} = 3.3$ V, and $V_{CC3} = 14$ V and $V_{CC1} = 3.3$ V, $V_{CC2} = 3.3$ V, and $V_{CC3} = 6$ V.

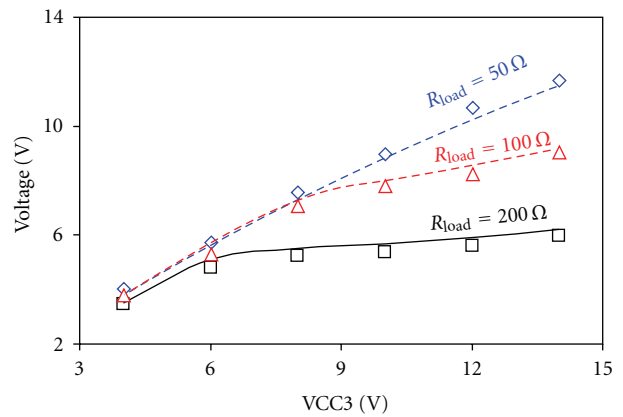


FIGURE 11: Measured (symbol) versus simulated (curve) amplitude of impulses generated with $V_{CC1} = 3.3$ V, $V_{CC2} = 6.5$ V, and $V_{CC3} = 4$ –14 V.

fabricated pulse generators was accurately predicted. For example, the output pulse amplitude could be varied linearly between 3.5 V and 11.5 V while maintaining the pulse width at 0.3 ± 0.1 nanosecond. Alternatively, the pulse width could be varied linearly between 0.25 nanosecond and 0.65 nanosecond while maintaining the pulse amplitude at 10 ± 1 V. Without adjusting the bias or input conditions, this performance was found to vary little when the ambient temperature was varied from -40°C to 85°C . These results show that the present pulse generator has much higher output capacity than those fabricated in CMOS ICs are and is much more compact than those fabricated in discrete devices are.

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